

L Number	Hits	Search Text	DB	Time stamp
1	9	((("4536608") or ("4554727") or ("4760440") or ("4826267") or ("5151917") or ("5417799") or ("5895233") or ("6359735") or ("6384473")).PN.	USPAT	2004/08/18 14:53
2	1	((("4536608") or ("4554727") or ("4760440") or ("4826267") or ("5151917") or ("5417799") or ("5895233") or ("6359735") or ("6384473")).PN.) and wafer and post\$4	USPAT	2004/08/18 14:54
3	1	((("4536608") or ("4554727") or ("4760440") or ("4826267") or ("5151917") or ("5417799") or ("5895233") or ("6359735") or ("6384473")).PN.) and wafer and post\$4 and cavity	USPAT	2004/08/18 14:55
4	1	((("4536608") or ("4554727") or ("4760440") or ("4826267") or ("5151917") or ("5417799") or ("5895233") or ("6359735") or ("6384473")).PN.) and wafer and post\$4 and cavity and etch\$4	USPAT	2004/08/18 14:55
5	1	((("4536608") or ("4554727") or ("4760440") or ("4826267") or ("5151917") or ("5417799") or ("5895233") or ("6359735") or ("6384473")).PN.) and wafer and post\$4 and cavity and etch\$4 and pattern	USPAT	2004/08/18 14:55
7	0	((("4536608") or ("4554727") or ("4760440") or ("4826267") or ("5151917") or ("5417799") or ("5895233") or ("6359735") or ("6384473")).PN.) and wafer and post\$4 and cavity and etch\$4 and pattern and field and mask	USPAT	2004/08/18 14:55
6	1	((("4536608") or ("4554727") or ("4760440") or ("4826267") or ("5151917") or ("5417799") or ("5895233") or ("6359735") or ("6384473")).PN.) and wafer and post\$4 and cavity and etch\$4 and pattern and field	USPAT	2004/08/18 14:55
8	3	"optical device" and infrared and pattern and field and post\$4 and etch\$4 and antireflection and seal\$4	USPAT	2004/08/18 14:58
-	1	("6627892").PN.	USPAT	2004/08/18 12:11
-	265	438/64.ccls.	USPAT	2004/08/18 12:11
-	11	438/64.ccls. and (wafer with mask\$4)	USPAT	2004/08/18 12:11
-	2	438/64.ccls. and (wafer with mask\$4)and field and post	USPAT	2004/08/18 12:12
-	1	438/64.ccls. and (wafer with mask\$4)and field and post and etch\$4	USPAT	2004/08/18 12:12
-	0	438/64.ccls. and (wafer with mask\$4)and field and post and etch\$4 and cavity	USPAT	2004/08/18 12:12
-	1	438/64.ccls. and (wafer with mask\$4)and field and post and etch\$4 and (cavity or trench or via or hole or opening)	USPAT	2004/08/18 12:12
-	1	438/64.ccls. and (wafer with mask\$4)and field and post and etch\$4 and (cavity or trench or via or hole or opening) and form\$4	USPAT	2004/08/18 12:13
-	109	438/64.ccls. and optical	USPAT	2004/08/18 12:13
-	19	438/64.ccls. and optical and infrared	USPAT	2004/08/18 12:13
-	12	438/64.ccls. and optical and infrared and wafer	USPAT	2004/08/18 12:13
-	12	438/64.ccls. and optical and infrared and wafer and field	USPAT	2004/08/18 12:13
-	1	438/64.ccls. and optical and infrared and wafer and field and post\$4	USPAT	2004/08/18 12:13

-	0	438/64.ccls. and optical and infrared and wafer and field and post\$4 and cavity	USPAT	2004/08/18 12:13
-	5	438/64.ccls. and optical and infrared and wafer and field and cavity	USPAT	2004/08/18 12:18
-	10	"infrared optical device"	USPAT	2004/08/18 12:19
-	1	"infrared optical device" and pattern and field and post	USPAT	2004/08/18 12:20
-	16478	"optical device"	USPAT	2004/08/18 12:20
-	2975	"optical device" and infrared	USPAT	2004/08/18 12:20
-	224	"optical device" and infrared and pattern and field and post\$4	USPAT	2004/08/18 12:21
-	13	"optical device" and infrared and pattern and field and post\$4 and etch\$4 and antireflection	USPAT	2004/08/18 12:21
-	1	"optical device" and infrared and pattern and field and post\$4 and etch\$4 and antireflection and seal\$4 and bolometer\$4	USPAT	2004/08/18 12:22
-	51	"optical device" and infrared and (mask with wafer)	USPAT	2004/08/18 12:23
-	1	"optical device" and infrared and (mask with wafer) and pattern and etch\$4 and post\$4 and cavity	USPAT	2004/08/18 14:52